



DPJ

Attention: Mr. Jose Chen
Patent Examiner, Art Unit 3637

From: Greg McLemore

Re: Collectable Display Shelf 10/617.144

5/10/05

Dear Mr. Chen

Thank you for your on going assistance in instructing me how to achieve my goal of writing my language to become allowable for my invention, I don't think I can do it without your patience and support. I know I have probably still gotten it wrong, but I am doing the best I can. I pray that you will continue to be patience with me and help me to get it right. Thank you in advance and I look forward to receiving your next office action so I can further refine my application through our next office interview.

Sincerely

Gregory J. McLemore